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By:

LINDA E. HASTINGS

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Attorney Docket No.: NECW 18.281

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: Toru TATSUMI et al.

Serial No.: 09/744,701

Filed: January 29, 2001

Title: **METHOD OF VAPOR PHASE GROWTH OF METAL OXIDE  
DIELECTRIC FILM AND APPARATUS FOR VAPOR PHASE  
GROWTH OF METAL DIELECTRIC MATERIAL**

Examiner: H. Jey Tsai

Group Art Unit: 2812

Assistant Commissioner for Patents  
Washington, D.C. 20231

**ELECTION**

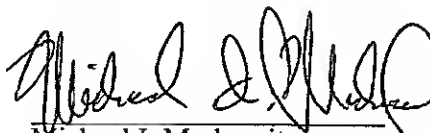
SIR:

In response to the Office Action mailed on May 29, 2002, the period for responding thereto having been set to expire after June 29, 2002, Applicant hereby elects Group II, claims 47-94, for prosecution at this time. Applicant reserves the right to file continuing application(s) based on claims 95-117. Early examination on the merits is earnestly solicited.

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Respectfully submitted,



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